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Date: April 6, 2004

To:

Name/Company	Fax No.	Phone No.
Examiner S. H. Rao U.S. PTO	(571) 273-1718	

From: Rebecca Goldman Rudich/E. Shavers Phone: (202) 496-7463

Number of Pages (including cover): 6

Message:

U.S. Application No. 09/875,197; filed June 7, 2001

Inventor(s): Joon-Young YANG

METHOD OF FABRICATING A THIN FILM TRANSISTOR

User No.	579	Client/Matter No.:	8733.423
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**PATENT/WASHINGTON**

File No.: **8733.132.20**

Attorney: **RGR/es**

MLA No.: **423**

Application No.: **09/875,197**

In the Matter of the Application of: **Joon-Young YANG**

For: **METHOD OF FABRICATING A THIN FILM  
TRANSISTOR**

Filed: **June 7, 2001**

Date: **April 6, 2004**

The following has been received in the U.S. Patent Office on the date stamped hereon:

1. Supplemental Amendment

**DUE DATE: April 6, 2004**

Docket No.: 8733.132.20-US  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Joon-Young Yang

Confirmation No.: 8761

Application No.: 09/875,197

Art Unit: 2814

Filed: June 7, 2001

Examiner: S. H. Rao

For: METHOD OF FABRICATING A THIN FILM  
TRANSISTOR

Customer No.: 30827

*M. Guler  
JM  
04/06/04*

SUPPLEMENTAL AMENDMENT

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Examiner's Final Office Action dated December 31, 2003 (Paper No. 12), Applicant respectfully requests that the above-identified Patent application be reconsidered in view of the remarks.

**List of the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.